

PTO-1449		Application No. 10/732,725		Applicant(s) Shmuel (nmi) Shaffer et al.			
<b>Information Disclosure Citation In an Application</b>		Docket Number 062891.1193		Group Art Unit 3661	Filing Date Dec. 10, 2003		
<b>U.S. PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
TN	A	5,928,307	07/27/99	Oshizawa et al.	701	210	01/15/97
TN	B	6,202,024 B1	03/13/01	Yokoyama et al.	701	207	03/18/99
TN	C	6,405,130 B1	06/11/02	Piowowski	701	210	12/11/96
	D						
	E						
	F						
	G						
	H						
	I						
	J						
<b>FOREIGN PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>
							<b>YES</b> <b>NO</b>
	K						
	L						
	M						
	N						
		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>					<b>DATE</b>
TN	O	PCT Search Report for PCT/US04/37694, 9 pages					July 7, 2005
	P						
	Q						
	R						
	S						
	T						
	U						
	V						
EXAMINER <i>Jan K. Miller</i>				DATE CONSIDERED <i>11/04/2005</i>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							